



07/27/01

Docket No. 006015/DISPLAY/AKT

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Box Patent Application  
 Assistant Commissioner for Patents  
 Washington, D.C. 20231

Re: Inventor(s): **Tae Kyung Won, Soo Young Choi, Takako Takehara and William R. Harshbarger**  
 Title: **Reduction of Electrostatic Charge on a Substrate during PECVD Process**



Transmitted herewith is the patent application identified above, including:0

- ☒ Specification, claims and abstract, totaling 30 pages.
- ☒ Drawings totaling 3 pages,    Formal ☒ Informal.
- ☒ Executed Declaration and Power of Attorney.
- ☒ Assignment of the invention to **Applied Materials, Inc.**
- ☒ Assignment Recordation Cover Sheet
- ☒ Information Disclosure Statement, PTO Form 1449 and (2) References

FEE CALCULATION					
Fee Items	Claims Filed	Included With Basic Fee	Extra Claims	Fee Rate	Total
Total Claims	- 35	- 20 =	-15	X \$18	\$270
Independent Claims	- 5	- 3 =	-2	X \$80	\$160
Basic Filing Fee				\$710	\$710
TOTAL FEES					\$1140

☒ The Commissioner is hereby authorized to charge \$1140 to Deposit Account No. 50-1074

☒ The Commissioner is hereby authorized to charge any additional fees which may be required, or credit any overpayment to Deposit Account No. 50-1074. A duplicate copy of this transmittal is enclosed.

☒ Please address all future correspondence to:

PATENT COUNSEL  
 APPLIED MATERIALS, INC.  
 Legal Affairs Department  
 P.O. BOX 450A  
 Santa Clara, CA. 95052

I hereby certify that this correspondence is being deposited with the United States Postal Service as express mail in an envelope addressed to: Box Patent Application, Assistant Commissioner for Patents, Washington, D.C. 20231

Express Mail Receipt No. EL 276123654US

Date of Deposit: 7-27-01

Signature: Robert W. Mulcahy

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Respectfully submitted,

Robert W. Mulcahy  
 Registration No. 25,436